118TH CONGRESS 2D SESSION  S.
To establish a grant program for education related to semiconductor manufacturing and related industries.
IN THE SENATE OF THE UNITED STATES
Mr. Kelly (for himself and Mr. Budd) introduced the following bill; which was read twice and referred to the Committee on

## A BILL

To establish a grant program for education related to semiconductor manufacturing and related industries.

- 1 Be it enacted by the Senate and House of Representa-
- 2 tives of the United States of America in Congress assembled,
- 3 SECTION 1. SHORT TITLE.
- 4 This Act may be cited as the "CHIPS Training in
- 5 America Act of 2024".

1	SEC. 2. AUTHORIZATION FOR THE CREATING HELPFUL IN-
2	CENTIVES TO PRODUCE SEMICONDUCTORS
3	(CHIPS) FOR AMERICA WORKFORCE AND
4	EDUCATION FUND.
5	Section 102(d) of Public Law 117–167 (commonly
6	known as the "CHIPS and Science Act of 2022") is
7	amended—
8	(1) in paragraph (1)—
9	(A) by inserting ", in consultation with the
10	Department of Commerce," after "National
11	Science Foundation"; and
12	(B) by inserting ", including establishment
13	and maintenance of a single publicly accessible
14	online clearinghouse of microelectronics edu-
15	cation and workforce development information"
16	before the period at the end of the paragraph;
17	(2) by redesignating paragraph (3) as para-
18	graph (6); and
19	(3) by inserting after paragraph (2) the fol-
20	lowing:
21	"(3) EVALUATION.—Not later than 90 days
22	after the date of enactment of the CHIPS Training
23	in America Act of 2024, the Director of the National
24	Science Foundation shall establish key performance
25	indicators to measure and monitor the impact of

1	Fund allocations on growing the microelectronics
2	workforce.
3	"(4) Workforce goals.—
4	"(A) Goals established.—Not later
5	than 90 days after the date of enactment of the
6	CHIPS Training in America Act of 2024, the
7	Director of the National Science Foundation
8	and the Secretary of Commerce shall jointly de-
9	velop quantitative goals for growing the domes-
10	tic semiconductor workforce.
11	"(B) Submission of Goals.—Such goals
12	shall be submitted to—
13	"(i) the Committee on Appropriations
14	of the Senate, the Committee on Com-
15	merce, Science, and Transportation of the
16	Senate, and the Committee on Health,
17	Education, Labor, and Pensions of the
18	Senate; and
19	"(ii) the Committee on Appropriations
20	of the House of Representatives, the Com-
21	mittee on Science, Space, and Technology
22	of the House of Representatives, and the
23	Committee on Education and the Work-
24	force of the House of Representatives.

1	"(5) National semiconductor technology
2	CENTER.—In this subsection, the term 'National
3	Semiconductor Technology Center' means the entity
4	established under section 9906(c) of the William M.
5	(Mac) Thornberry National Defense Authorization
6	Act for Fiscal Year 2021 (15 U.S.C. 4656(c)).".
7	SEC. 3. AUTHORIZATION OF NATIONAL SEMICONDUCTOR
8	TECHNOLOGY CENTER ACTIVITIES.
9	Section 9906(e)(2) of the William M. (Mac) Thorn-
10	berry National Defense Authorization Act for Fiscal Year
11	2021 (15 U.S.C. 4656(c)(2)) is amended—
12	(1) in subparagraph (C)—
13	(A) in clause (i), by striking "and" after
14	the semicolon;
15	(B) in clause (ii), by striking the period at
16	the end and inserting "; and"; and
17	(C) by adding at the end the following:
18	"(iii) the development of competency-
19	based degree, credentialing, and certificate
20	frameworks to increase standardization
21	within semiconductor and microelectronics
22	workforce development programs."; and
23	(2) by inserting the following after subpara-
24	graph (C):

1	"(D)(i) Subject to clause (ii), in coordina-
2	tion with the National Science Foundation, as-
3	sist in the management and maintenance of the
4	single publicly accessible online clearinghouse
5	authorized in section 102(d) of Public Law
6	117–167.
7	"(ii) If the National Science Foundation
8	and the National Semiconductor Technology
9	Center agree, the National Semiconductor
10	Technology Center may take over primary man-
11	agement and maintenance of such single pub-
12	liely accessible online clearinghouse, with sup-
13	port from the National Science Foundation.".
14	SEC. 4. NATIONAL STRATEGY ON MICROELECTRONICS
15	WORKFORCE.
16	Section 9906(a) of the William M. (Mac) Thornberry
17	National Defense Authorization Act for Fiscal Year 2021
18	(15 U.S.C. 4656(a)) is amended—
19	(1) in paragraph (2)—
20	(A) by redesignating subparagraph (I) as
21	subparagraph (J); and
22	(B) by inserting after subparagraph (H)
23	the following:
24	"(I) For purposes of the duties described

1	Secretary of Labor, the Secretary of Education,
2	and the Secretary of Veterans Affairs.".
3	(2) in paragraph (3), by inserting after sub-
4	paragraph (C) the following:
5	"(D) NATIONAL STRATEGY ON MICRO-
6	ELECTRONICS WORKFORCE.—
7	"(i) In general.—
8	"(I) NATIONAL STRATEGY ON
9	MICROELECTRONICS WORKFORCE DE-
10	VELOPMENT.—Not later than 1 year
11	after the date of enactment of the
12	CHIPS Training in America Act of
13	2024, in consultation with appropriate
14	stakeholders in the microelectronics
15	industry, relevant researchers or ex-
16	perts at institutions of higher edu-
17	cation, economic development organi-
18	zations, and other apposite stake-
19	holders, the Subcommittee shall de-
20	velop a 5-year national strategy on
21	microelectronics workforce develop-
22	ment.
23	"(II) Additional sub-
24	COMMITTEE MEMBERS.—For the pur-
25	poses of this subparagraph only such

1	Subcommittee shall also include the
2	Secretary of Labor, the Secretary of
3	Education, and the Secretary of Vet-
4	erans Affairs.
5	"(ii) Elements.—The strategy devel-
6	oped under this subparagraph shall—
7	"(I) specify and prioritize annual
8	and long-term objectives, including
9	the role of each agency in supporting
10	programs and activities designed to
11	meet the objectives, to ensure a ro-
12	bust, skilled domestic microelectronics
13	workforce;
14	"(II) specify the common metrics
15	that will be used to assess progress
16	toward achieving the objectives;
17	"(III) describe the roles of and
18	means of coordination with elemen-
19	tary and secondary, and postsec-
20	ondary, education systems in achiev-
21	ing the objectives;
22	"(IV) describe how Federal fund-
23	ing will be used to support the strat-
24	egy's microelectronics workforce ini-
25	tiatives;

1	"(V) describe the approaches to
2	be taken by each participating agency
3	to assess the effectiveness of the agen-
4	cy's microelectronics workforce pro-
5	grams and activities;
6	"(VI) describe how objectives
7	outlined in the strategic plan will
8	align with investments made using
9	funds from divisions A and B of Pub-
10	lie Law 117–167 (commonly known as
11	the 'CHIPS and Science Act of
12	2022');
13	"(VII) describe how objectives
14	outlined in the strategic plan will
15	align with the objectives of the 5-year
16	STEM education strategic plan re-
17	quired under section 101 of the Amer-
18	ica COMPETES Reauthorization Act
19	of 2010 (42 U.S.C. 6621);
20	"(VIII) describe how objectives
21	outlined in the strategic plan will
22	align with the objectives of the na-
23	tional strategy on microelectronics re-
24	search, as required under subpara-
25	graph (A), as applicable; and

1	"(IX) be made publicly available
2	through the online clearinghouse au-
3	thorized in section 102(d) of Public
4	Law 117–167.
5	"(iii) Fostering coordination of
6	WORKFORCE PROGRAMS.—The Sub-
7	committee shall coordinate programs and
8	activities of Federal agencies relating to
9	microelectronics workforce development,
10	and ensure such programs and activities
11	are consistent with the strategy required
12	under this subparagraph.
13	"(iv) Reporting and updates .—
14	Not less frequently than once every 5
15	years, the Subcommittee shall—
16	"(I) update the strategy under
17	this subparagraph;
18	"(II) submit the revised strategy
19	to the appropriate committees of Con-
20	gress; and
21	"(III) make such strategy pub-
22	licly available through the online
23	clearinghouse authorized in section
24	102(d) of Public Law 117–167.".

1	SEC. 5. GRANT PROGRAM FOR EDUCATION RELATED TO
2	SEMICONDUCTOR MANUFACTURING AND RE-
3	LATED INDUSTRIES.
4	Division H of title XCIX of the William M. (Mac)
5	Thornberry National Defense Authorization Act for Fiscal
6	Year 2021 (15 U.S.C. 4651 et seq.) is amended by insert-
7	ing after section 9906 the following:
8	"SEC. 9906A. WORKFORCE DEVELOPMENT ACTIVITIES.
9	"(a) Definitions.—In this section:
10	"(1) Eligible institution.—The term 'eligi-
11	ble institution' means—
12	"(A) an institution of higher education, as
13	defined in section 101 of the Higher Education
14	Act of 1965 (20 U.S.C. 1001), at which the
15	highest degree predominantly awarded to stu-
16	dents is not a baccalaureate degree or higher
17	degree;
18	"(B) a postsecondary vocational institu-
19	tion, as defined in section 102(c) of the Higher
20	Education Act of 1965 (20 U.S.C. 1002(e));
21	and
22	"(C) an area career and technical edu-
23	cation school, as defined in subparagraphs (A)
24	or (B) of section 3(3) of the Carl D. Perkins
25	Career and Technical Education Act of 2006
26	(20 U.S.C. 2302(3)).

1	"(2) ELIGIBLE PARTNERSHIP.—The term 'eligi-
2	ble partnership' means a partnership that—
3	"(A) includes—
4	"(i) an eligible institution;
5	"(ii) a covered entity; and
6	"(iii) a State, Indian Tribe, or polit-
7	ical subdivision thereof; and
8	"(B) may include other entities.
9	"(3) National semiconductor technology
10	CENTER.—The term 'National Semiconductor Tech-
11	nology Center' means the entity established under
12	section 9906(c).
13	"(b) Grants Authorized.—The National Semicon-
14	ductor Technology Center shall make awards, on a com-
15	petitive basis, to eligible partnerships to establish or ex-
16	pand workforce development and academic programs of-
17	fered by an eligible institution (which may include short-
18	term programs or non-credit programs offered by that eli-
19	gible institution), related to semiconductor manufacturing
20	and related equipment, materials, advanced packaging,
21	microelectronics, computer science, engineering, and re-
22	lated industries.
23	"(c) Application.—An eligible partnership desiring
24	a grant under this section shall submit an application to
25	the National Semiconductor Technology Center at such

time, in such manner, and containing such information as the National Semiconductor Technology Center may re-2 3 quire. The application shall require— 4 "(1) a description of the eligible partnership; 5 "(2) a description of the workforce needs that 6 will be addressed through the activities funded by 7 the grant; 8 "(3) a description of the eligible partnership's 9 strategy to sustain such activities after the grant pe-10 riod; 11 "(4) a description of how the eligible partner-12 ship will recruit and retain individuals with barriers 13 to employment (as defined in section 3 of the Work-14 force Innovation and Opportunity Act definition (29) 15 U.S.C. 3102)) in programs that receive grant fund-16 ing; and 17 "(5) a description of how programs supported 18 by grants under this subsection align with the work-19 force pathways and credential frameworks estab-20 lished by the National Semiconductor Technology Center or the National Science Foundation. 21 22 "(d) Selection.—In selecting eligible partnerships 23 to receive a grant under this section, the National Semiconductor Technology Center shall give priority to eligible 25 partnerships located in areas with growing microelec-

- 1 tronics ecosystems, as determined by the National Semi-
- 2 conductor Technology Center, that serve or intend to serve
- 3 as members of broader sectoral partnerships and coordi-
- 4 nate with State and local workforce development boards
- 5 (as established under sections 101 and 107 of the Work-
- 6 force Innovation and Opportunity Act (29 U.S.C. 3111;
- 7 29 U.S.C. 3122)), respectively.
- 8 "(e) Amount; Duration.—
- 9 "(1) Amount.—A grant awarded under this
- section shall be for an amount equal to or less than
- \$7,000,000.
- 12 "(2) DURATION.—A grant awarded under this
- section shall be for a period not to exceed 5 years.
- 14 "(f) Federal Cost Share.—
- 15 "(1) Maximum federal share.—The Federal
- share of the costs of a grant under this section shall
- not exceed 50 percent of such costs.
- 18 "(2) REQUIRED WORKER AND COMMUNITY IN-
- 19 VESTMENTS.—Non-Federal costs contributed by a
- 20 covered entity under this section shall be considered
- as part of an eligible entity's commitments to worker
- and community investments as required under sec-
- 23 tion 9902(a)(2)(B)(ii)(II).
- 24 "(g) Report.—

1	"(1) Report to the national semicon-
2	DUCTOR TECHNOLOGY CENTER.—Each eligible part-
3	nership receiving a grant under this section shall
4	prepare and submit an annual report to the National
5	Semiconductor Technology Center that contains in-
6	formation about each of the following with respect to
7	individuals participating in a program funded by a
8	grant under this section:
9	"(A) The total number of participants
10	disaggregated by sex, race, and ethnicity.
11	"(B) The total number of participants who
12	completed the program.
13	"(C) The indicators required by section
14	116(b)(2)(A)(i) of the Workforce Innovation
15	and Opportunity Act (29 U.S.C.
16	3141(b)(2)(A)(i).
17	"(2) Report to congress.—Not later than
18	180 days of receiving the annual report under para-
19	graph (1), the National Semiconductor Technology
20	Center shall—
21	"(A) prepare and submit a report con-
22	taining a summary of the information described
23	in paragraph (1) to the Committee on Com-
24	merce, Science, and Transportation and the
25	Committee on Health, Education, Labor, and

1	Pensions of the Senate and the Committee on
2	Science, Space, and Technology and the Com-
3	mittee on Education and the Workforce of the
4	House of Representatives; and
5	"(B) make such report publicly available.
6	"(h) Authorization of Appropriations .—There
7	are authorized to carry out this section \$50,000,000 for
8	each of fiscal years 2025, 2026, and 2027.".
O	, , ,
9	SEC. 6. PROHIBITION ON ADDITIONAL MICROELECTRONICS
9	, ,
9 10	SEC. 6. PROHIBITION ON ADDITIONAL MICROELECTRONICS
9 10 11	SEC. 6. PROHIBITION ON ADDITIONAL MICROELECTRONICS  EDUCATION AND WORKFORCE CLEARING-
	SEC. 6. PROHIBITION ON ADDITIONAL MICROELECTRONICS  EDUCATION AND WORKFORCE CLEARING- HOUSE.
9 10 11 12 13	SEC. 6. PROHIBITION ON ADDITIONAL MICROELECTRONICS  EDUCATION AND WORKFORCE CLEARING- HOUSE.  A Federal agency shall not establish a microelec-
9 110 111 12 13 14	SEC. 6. PROHIBITION ON ADDITIONAL MICROELECTRONICS  EDUCATION AND WORKFORCE CLEARING- HOUSE.  A Federal agency shall not establish a microelectronics education and workforce clearinghouse that is du-